



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813  
Examiner: Heather Doty  
Confirmation No.: 2155

**In Re PATENT APPLICATION of:**

Applicant(s): Hirotaka KOMATSUBARA )  
Serial No.: 10/765,156 )  
Filing Date: January 28, 2004 ) AMENDMENT  
For: METHOD FOR MANUFACTURING SOI ) UNDER  
LOCOS MOSFET WITH METAL OXIDE )  
FILM OR IMPURITY-IMPLANTED FIELD ) RULE 312  
OXIDE (as amended) )  
Atty. Docket: KAN 155 )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please enter the attached Replacement Sheet to correct the inadvertent submission of an explanatory sketch as a drawing change, in the last amendment. The attached sheet merely reinstates the original drawing sheet that was already approved, and removes the error of the last amendment. The Applicant regrets any inconvenience to the PTO.

Respectfully submitted,

August 16, 2005  
Date